

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Application No. 09/620,968

Filed: July 20, 2000

For: METHOD OF FORMING INSULATION)
FILMS CAPACITANCES, AND)
SEMICONDUCTOR DEVICES)



) Group Art Unit: 2814
Examiner: Nathan W. Ha
Confirmation No. 4214

) Date: March 7, 2005

AMENDMENT

Mail Stop **RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Further to the Notice of Appeal filed on November 5, 2004, please amend the above identified application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

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